

Public Products List

Publict Products are off the shelf products. They are not dedicated to specific customers, they are available through ST Sales team, or Distributors, and visible on ST.com

PCN Title: ASE Kaohsiung (Taiwan) LQFP7x7 and LQFP10x10 package capacity increase - on listed of products

PCN Reference: MDG/22/13388

Subject: Public Products List

Dear Customer,

Please find below the Standard Public Products List impacted by the change.

| STM32G070CBT6 | STM32G431R8T6 | STM32G070RBT6TR |
|-----------------|-----------------|-----------------|
| STM32G071C8T6 | STM32G431RBT6TR | STM32G431RBT3 |
| STM32G431RBT6 | STM32G070CBT6TR | STM32L471RET3TR |
| STM32G071CBT3 | STM32G081RBT6 | STM32G071R8T6 |
| STM32L431RCT6TR | STM32L471RET3 | STM32G071C8T6TR |
| STM32L496RGT6P | STM32G431RBT3TR | STM32G081CBT6 |
| STM32G081CBT6TR | STM32G071RBT7TR | STM32L496RET6TR |
| STM32L496RGT3TR | STM32G071CBT7 | STM32L433RCT3TR |
| STM32G081RBT3 | STM32G441RBT6 | STM32G071RBT7 |
| STM32L471RET6TR | STM32G431R6T6 | STM32L475RGT6TR |
| STM32L4A6RGT6P | STM32G071RBT3 | STM32G071C8T3 |

IMPORTANT NOTICE - PLEASE READ CAREFULLY

Subject to any contractual arrangement in force with you or to any industry standard implemented by us, STMicroelectronics NV and its subsidiaries ("ST") reserve the right to make changes, corrections, enhancements, modifications, and improvements to ST products and/or to this document at any time without notice. Purchasers should obtain the latest relevant information on ST products before placing orders. ST products are sold pursuant to ST's terms and conditions of sale in place at the time of order acknowledgement.

Purchasers are solely responsible for the choice, selection, and use of ST products and ST assumes no liability for application assistance or the design of Purchasers' products.

No license, express or implied, to any intellectual property right is granted by ST herein.

Resale of ST products with provisions different from the information set forth herein shall void any warranty granted by ST for such product.

ST and the ST logo are trademarks of ST. All other product or service names are the property of their respective owners.

Information in this document supersedes and replaces information previously supplied in any prior versions of this document.

© 2018 STMicroelectronics - All rights reserved



PRODUCT/PROCESS CHANGE NOTIFICATION PCN13388

- Additional information

ASE Kaohsiung (Taiwan) LQFP7x7 and LQFP10x10 package capacity increase - on listed of products

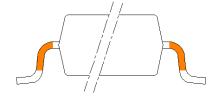
MDG - Microcontrollers Division (MCD)

What are the changes?

Changes described in table below:

| | Existing back-end sites | Added back-end site |
|--------------------------|-------------------------|---------------------|
| Assembly site | Stats ChipPAC JSCC | ASE |
| | Jiangyin China | Kaohsiung Taiwan |
| Leadframe | Copper Frame | Copper Frame |
| | Spot Ag | Spot Ag |
| Leadfinishing (1) | Pure Tin (e3) | Pure Tin (e3) |
| Resin (2) | Sumitomo | Sumitomo |
| | G631SHQ | G631SH |
| Glue | Ablestik | Sumitomo |
| | 3230 | CRM 1076WA |
| Wire | Silver 96.5% 0.8mil | Gold 0.8mil |
| Enhanced Traceability in | 2 digits | 2 digits |
| marking | | |

(1) Lead color and surface finish change depending on leadfinishing.



(2) Package darkness changes depending on molding compound.

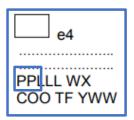
Pin1 identifier can change in terms of form and positioning.

Marking position and size could be different upon assembly site, without any loss of information.



How can the change be seen?

The standard marking is:



PP code indicates assembly traceability plant code.

Please refer to <u>DataSheet</u> for marking details.

The marking is changing as follows:

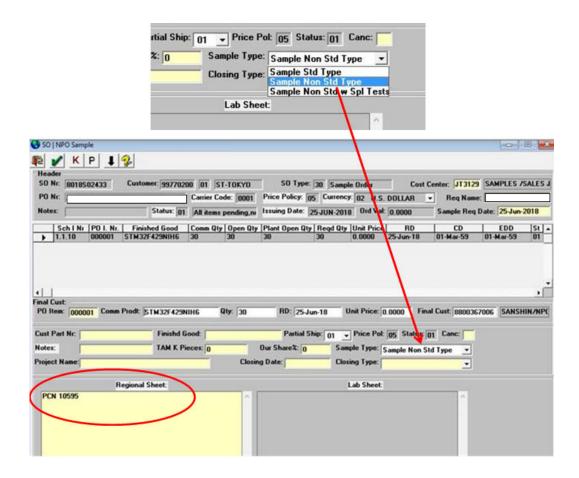
| Existing | | Additional | | |
|----------|--------------------------------------|------------|----------------------|--|
| PP code | Fab | PP code | Fab | |
| GQ | Stats ChipPAC JSCC Jiangyin China | AA | ASE Kaohsiung Taiwan | |



How to order samples?

For all samples request linked to this PCN, please:

- place a Non-standard sample order (choose Sample Non Std Type from pull down menu)
- insert the PCN number "PCN13388" into the NPO Electronic Sheet/Regional Sheet
- request sample(s) through Notice tool, indicating a single Commercial Product for each request





IMPORTANT NOTICE - PLEASE READ CAREFULLY

STMicroelectronics International NV and its affiliates ("ST") reserve the right to make changes corrections, enhancements, modifications, and improvements to ST products and/or to this document any time without notice. This document is provided solely for the purpose of obtaining general information relating to an ST product. Accordingly, you hereby agree to make use of this document solely for the purpose of obtaining general information relating to the ST product. You further acknowledge and agree that this document may not be used in or in connection with any legal or administrative proceeding in any court, arbitration, agency, commission or other tribunal or in connection with any action, cause of action, litigation, claim, allegation, demand or dispute of any kind. You further acknowledge and agree that this document shall not be construed as an admission, acknowledgement or evidence of any kind, including, without limitation, as to the liability, fault or responsibility whatsoever of ST or any of its affiliates, or as to the accuracy or validity of the information contained herein, or concerning any alleged product issue, failure, or defect. ST does not promise that this document is accurate or error free and specifically disclaims all warranties, express or implied, as to the accuracy of the information contained herein. Accordingly, you agree that in no event will ST or its affiliates be liable to you for any direct, indirect, consequential, exemplary, incidental, punitive, or other damages, including lost profits, arising from or relating to your reliance upon or use of this document.

Purchasers should obtain the latest relevant information on ST products before placing orders. ST products are sold pursuant to ST's terms and conditions of sale in place at the time of order acknowledgement, including, without limitation, the warranty provisions thereunder.

In that respect please note that ST products are not designed for use in some specific applications or environments described in above mentioned terms and conditions.

Purchasers are solely responsible for the choice, selection, and use of ST products and ST assumes no liability for application assistance or the design of Purchasers' products.

Information furnished is believed to be accurate and reliable. However, ST assumes no responsibility for the consequences of use of such information nor for any infringement of patents or other rights of third parties which may result from its use. No license, express or implied, to any intellectual property right is granted by ST herein. Resale of ST products with provisions different from the information set forth herein shall void any warranty granted by ST for such product.

ST and ST logo are trademarks of ST. All other product or service names are the property of their respective owners.

Information in this document supersedes and replaces information previously in any prior version of this document.

© 2022 STMicroelectronics - All rights reserved



Qualification Type: ASSEMBLY LINE QUALIFICATION

ASE Kaohsiung (Taiwan) additional source for LQFP 7x7, LQFP 10x10, LQFP14x14 & LQFP20x20 extended listed products

(PCN10548) (PCN10549) (PCN10689) (PCN12854)

| Product / Proc | Product / Process / Package Information for test vehicles | | | | | | |
|----------------------------------|---|---------------------------------|--|--|--|--|--|
| Commercial Product | STM8L052C6T6 STM32F303CBT7 | STM32F205RET6 STM32L052R8T6 | STM32L151VDT6 STM32F071VBT6 STM32F207VET6 STM32L431VCT6 | STM32F103ZET6 STM32F405ZGT6 STM32H743ZIT6 | | | |
| Mask Set Revision | F764XXXY F422XXXY | E411XXX3 F417XXXX | F436XXXX F448XXX1 E411XXX3 E435XXXZ | F414XXX3 E413XXX2 E450XXXY | | | |
| Silicon Process Technology | CMOSF9GO2 CMOS0.18µm Emb.Flash | CMOSM10ULP 6M1T CMOSF9GO2s | CMOSF9GO2 CMOS0.18µm Emb.Flash CMOSM10ULP 6M1T 90nm eFlash Generic TSMC | CMOS0.18µm Emb.Flash CMOSM10LP 6M1T CMOSM40 | | | |
| Wafer Fabrication Location | ROUSSET R8 TSMC Fab11 US | TSMC Fab14 Taiwan ROUSSET R8 | ROUSSET R8 TSMC Fab8 Taiwan TSMC Fab14 Taiwan TSMC Fab14 Taiwan | TSMC Fab8 Taiwan ST Crolles 300 ST Crolles 300 | | | |
| Package | LQFP 7x7x1.4 48L | LQFP 10x10x1.4 64L | LQFP 14x14x1.4 100 | LQFP 20x20x1.4 144 | | | |
| Assembly Plant Location | ASE Kaohsiung (Taiwan) | | | | | | |

MDG-MCD-RER1810 Page 1 of 21



| Approval List rev 1 | | | | | | | |
|-----------------------------------|------------|---------------|---------------|--|--|--|--|
| Function | Location | Name | Date | | | | |
| Division Back-End Quality Manager | ST Rousset | Gisèle SEUBE | 30 Nov., 2018 | | | | |
| Division Quality Manager | ST Rousset | Pascal NARCHE | 30 Nov., 2018 | | | | |
| Approval List rev 2 | | | | | | | |
| Function | Location | Name | Date | | | | |
| Division Back-End Quality Manager | ST Rousset | Gisèle SEUBE | 17 Jan., 2019 | | | | |
| Division Quality Manager | ST Rousset | Pascal NARCHE | 17 Jan., 2019 | | | | |
| Approval List rev 3 | | | | | | | |
| Function | Location | Name | Date | | | | |
| Division Back-End Quality Manager | ST Rousset | Gisèle SEUBE | 26 Apr., 2019 | | | | |
| Division Quality Manager | ST Rousset | Pascal NARCHE | 2 May, 2019 | | | | |
| Approval List rev 4 | | | | | | | |
| Function | Location | Name | Date | | | | |
| Division Back-End Quality Manager | ST Rousset | Gisèle SEUBE | 25 Jun.,2019 | | | | |
| Division Quality Manager | ST Rousset | Pascal NARCHE | 25 Jun.,2019 | | | | |
| Approval List rev 5 | | | | | | | |
| Function | Location | Name | Date | | | | |
| Division Back-End Quality Manager | ST Rousset | Gisèle SEUBE | 25 Jun.,2021 | | | | |

MDG-MCD-RER1810 Page 2 of 21



Contents

| 1 | REL | LIABILITY RESULTS OVERVIEW | Z |
|---|-----|--|----|
| | 1.1 | Objectives | ∠ |
| | 1.2 | Conclusion | |
| 2 | REL | LIABILITY EVALUATION CONTEXT / PLAN / STRATEGY & RESULTS SUMMARY | 5 |
| | 2.1 | Reliability Evaluation: Context & strategy summary | 5 |
| | 2.2 | Reliability Test vehicles description | 6 |
| | 2.3 | Reliability Information | 7 |
| | 2.4 | Reliability Evaluation: Results summary | 8 |
| 3 | REL | LIABILITY TEST VEHICLES CHARACTERISTICS | 12 |
| | 3.1 | Front-End information | 12 |
| | 3.2 | Back-End information | 16 |
| 4 | APF | PLICABLE AND REFERENCE DOCUMENTS | 20 |
| 5 | GLO | DSSARY AND TESTS DESCIPTION | 20 |
| 6 | RE\ | /ISION HISTORY | 20 |

MDG-MCD-RER1810 Page 3 of 21



1 RELIABILITY RESULTS OVERVIEW

1.1 Objectives

The assembly line LQFP7x7 is qualified and in production for STM32 devices (please refer to report MDG-MCD-RER1717).

The aim of this report is to present results of the reliability evaluation for LQFP 7x7, LQFP 10x10, LQFP 14X14 & LQFP20x20 package manufactured at ASE Kaohsiung (Taiwan) assembly and test plant for STM8L and STM32 extended devices.

Test vehicles are described here below:

| Product | Package | Assembly plant |
|---------------|--------------------|------------------------|
| STM8L052C6T6 | LQFP 48 7x7x1.4 | |
| STM32F303CBT7 | LQFP 46 / X/X1.4 | |
| STM32F205RET6 | LOED 64 10v10v1 4 | |
| STM32L052R8T6 | LQFP 64 10x10x1.4 | |
| STM32L151VDT6 | | |
| STM32F071VBT6 | LQFP 100 14x14x1.4 | ASE Kaohsiung (Taiwan) |
| STM32F207VET6 | | |
| STM32L431VCT6 | | |
| STM32F103ZET6 | | |
| STM32F405ZGT6 | LQFP 144 20x20x1.4 | |
| STM32H743ZIT6 | | |

Qualification is based on standard STMicroelectronics Corporate Procedures for Quality and Reliability, in full compliancy with the JESD-47 international standard

1.2 Conclusion

All reliability tests have been completed with positive results for LQFP7x7, LQFP10x10, LQFP14x14 & LQFP20x20. Neither functional nor parametric rejects were detected at final electrical testing.

So, according to good reliability tests results in line with validated product mission profile and reliability strategy, the qualification is granted for the LQFP7x7, LQFP10x10, LQFP14x14 & LQFP20x20 assembly and test line at ASE Kaohsiung (Taiwan).

Refer to Section 2.0 for reliability test results.

MDG-MCD-RER1810 Page 4 of 21



2 RELIABILITY EVALUATION CONTEXT / PLAN / STRATEGY & RESULTS SUMMARY

2.1 Reliability Evaluation: Context & strategy summary

Due to the success on the market of STM8L & STM32 devices, ST Microcontrollers Division decided to qualify an additional back-end site to maintain state of the art service level to our customers thanks to extra capacity. This reliability evaluation concerns the qualification of a new assembly line for LQFP 7x7, LQFP 10x10, LQFP 14x14 and LQFP 20x20 package in ASE Kaohsiung (Taiwan).

PCN10548 - Changes are described here below for LQFP7x7 & LQFP10x10:

| | E | Added back-end site | | |
|----------------------------------|---|------------------------------------|--------------------------|-------------------------|
| Assembly site | Stats ChipPAC JSCC Jiangyin China | ST Muar Malaysia | Amkor ATP Philippines | ASE Kaohsiung Taiwan |
| Lead frame supplier | Copper Frame Spot Ag | Pre Plated Frame | Copper Frame Spot Ag | Copper Frame Spot Ag |
| Leadfinishing (1) | Pure Tin (e3) | Ni Pd Au (e4) | Pure Tin (e3) | Pure Tin (e3) |
| Molding compound (2) | Sumitomo G631SHQ | Sumitomo G700LS | Sumitomo G631HQ | Sumitomo G631SH |
| Die attach Glue | Ablestik 3230 | Hitachi EN4900 | Evertech AP4200 | Sumitomo CRM 1076WA |
| Wire | Silver 96.5% 0.8mil | Gold 0.8mil Silver 96.5% 0.8mil | Gold 0.8mil | Gold 0.8mil |
| Enhanced traceability in marking | 2 digits | 2 digits | No digit | 2 digits |

PCN10689 - Changes are described here below for LQFP14x14:

| | E | Added back-end site | | |
|----------------------------------|---------------------|-------------------------|--------------------------|-------------------------|
| Assembly site | ST Muar Malaysia | ST Muar Malaysia | Amkor ATP Philippines | ASE Kaohsiung Taiwan |
| Lead frame supplier | Pre Plated Frame | Copper Frame Spot Ag | Copper Frame Spot Ag | Copper Frame Spot Ag |
| Leadfinishing (1) | Ni Pd Au (e4) | Pure Tin (e3) | Pure Tin (e3) | Pure Tin (e3) |
| Molding compound (2) | Sumitomo G700LS | Sumitomo G700LS | Sumitomo G631HQ | Sumitomo G631SH |
| Die attach Glue | Henkel 3280T | Henkel ABP8302 | Evertech AP4200 | Sumitomo CRM 1076WA |
| Wire | 1.0mil Au | 0.8mil Ag | 0.8mil Au | 0.8mil Au |
| Enhanced traceability in marking | No digit | 2 digits | No digit | 2 digits |

MDG-MCD-RER1810 Page 5 of 21



PCN10549 - Changes are described here below for LQFP20x20:

| | Existing Back-end sites | | | | Added back-end site |
|----------------------------------|--|-----------------------|------------------------|--------------|-------------------------|
| Assembly site | А | Amkor ATP Philippines | | | |
| Lead frame supplier | Copper Frame Spot Ag Coppe | | | Copper Frame | Copper Frame Spot Ag |
| Leadfinishing (1) | Pure Tin (e3) PPF (e4) | | | PPF (e4) | Pure Tin (e3) |
| Molding compound (2) | Sumitomo Sumitomo G631HQ | | | tomo G631HQ | Sumitomo G631SH |
| Die attach Glue | Ablestik 3230 Evertech AP4200 Sumitomo CRM1076YB | | Sumitomo CRM 1076WA | | |
| Enhanced traceability in marking | No digit | | | | 2 digits |

PCN12854 - Changes are described here below for LQFP7x7, for additional listed products in PCN:

| | Existing Back-end site | Added back-end site |
|----------------------|-----------------------------------|----------------------|
| Assembly site | Stats ChipPAC JSCC Jiangyin China | ASE Kaohsiung Taiwan |
| Molding compound (2) | Sumitomo | Sumitomo |
| | G631SHQ | G631SH |
| Die attach Glue | Ablestik | Sumitomo |
| | 3230 | CRM 1076WA |
| Wire | Silver 96.5% 0.8mil | Gold 0.8mil |

(1) Lead color and surface finish change depending on leadfinishing.



(2) Package darkness changes depending on molding compound.

2.2 Reliability Test vehicles description

| Package | Assembly | Package | Device | Diffusion | Number Reliability |
|---------|------------|-----------------|------------------------|-------------------|--------------------|
| line | Line | . aonago | (Partial RawLine Code) | Process | Lots |
| | LQFP 7*7 | 48L | STM8(5B*764) | Rousset R8 F9GO2 | 1 |
| | LQFF / / | 40L | STM32(5B*422) | TSMC 0.18µm | 1 |
| | LQFP 10*10 | 64L | STM32(5W*411) | TSMC M10 | 1 |
| | LQFF 10 10 | 04L | STM32(5W*417) | Rousset R8 F9GO2s | 1 |
| | | 100L | STM32(1L*436) | Rousset R8 F9GO2 | 1 |
| LQFP | LQFP 14*14 | | STM32(1L*448) | TSMC 0.18µm | 1 |
| | | | STM32(1L*411) | TSMC M10 | 1 |
| | | | STM32(1L*435) | TSMC 90nm | 1 |
| | LQFP 20*20 | LQFP 20*20 144L | STM32(1A *414) | TSMC 0.18µm | 1 |
| | | | STM32(1A *413) | Crolles CR300 M10 | 1 |
| | | | STM32(1A *450) | Crolles CR300 M40 | 1 |

MDG-MCD-RER1810



2.3 Reliability Information

| Pr | Product / Process / Package Information for test vehicles | | | | | | |
|-----------------------------|---|----------------------|--------------------------------|----------------------|--|--|--|
| Finish Good | ES8L052 C6T6\$E6 | ES32F303 CBT7\$E3 | ES32F205 RET6\$EA | ES32L052 R8T6\$E4 | | | |
| Die Name /cut | F764XXXY | F422XXXY | E411XXX3 | F417XXXX | | | |
| Diffusion Lot Number | VG808155 | 9U804096 | 9R807141 | VG815029 | | | |
| Trace Code | AA824048 | AA830068 | AA824059 | AA824047 | | | |
| Reliability Lab location | | | SSET (France) AR (Malaysia) | | | | |
| Fab name location | ROUSSET R8 | TSMC Fab11 US | TSMC Fab14 Taiwan | ROUSSET R8 | | | |
| Assembly Plant Location | ASE Kaohsiung (Taiwan) | | | | | | |
| Package description | LQFP 4 | 8 7x7x1.4 | LQFP 64 10x10x1.4 | | | | |

| Product / | Product / Process / Package Information for test vehicles | | | | | | | |
|-----------------------------|---|------------------------|----------------------|---------------------------------|----------------------|----------------------|----------------------|--|
| Finish Good | ES32L151 VDT6\$E1 | ES32F071 VBT6\$E1 | ES32F207 VET6\$EA | ES32L431 VCT6\$E2 | ES32F103 ZET6\$EA | ES32F405 ZGT6\$E4 | ES32H743 ZIT6\$E3 | |
| Die Name /cut | F436XXXX | F448XXX1 | E411XXX3 | E435XXXZ | F414XXX3 | E413XXX2 | E450XXXY | |
| Diffusion Lot Number | VG813171 | 98815033 | 9R807141 | 9R807069 | 98812034 | VQ749877 | VQ743682 | |
| Trace Code | AA826001 | AA826003 | AA826002 | AA836029 | AA838038 | AA845065 | AA904060 | |
| Reliability Lab location | | | | ROUSSET (Frar T MUAR (Malays | , | | | |
| Fab name location | ROUSSET R8 | TSMC Fab8 Taiwan | TSMC Fab14 Taiwan | TSMC Fab14 Taiwan | TSMC Fab8 Taiwan | ST Crolles 300 | ST Crolles 300 | |
| Assembly Plant Location | | ASE Kaohsiung (Taiwan) | | | | | | |
| Package description | | LQFP 10 | 00 14x14x1.4 | | LC | QFP 100 20x20: | x1.4 | |

Comment:

ST is certified ISO/TS 16949. This induces certification for all internal and subcontractor plants ST certification document can be downloaded under the following link: http://www.st.com/content/st_com/en/support/quality-and-reliability/certifications.html

MDG-MCD-RER1810 Page 7 of 21



2.4 Reliability Evaluation: Results summary

Package oriented test results in LQFP7x7

| Package Related Tests | | | | | | | sults |
|-----------------------|--|-------------------------------------|--------------|---|--------------------------|--------------|--------------|
| | | | Sample | | Readout / | | P 7x7 |
| Description | Test/Method | Conditions | Size | Criteria | Duration | Lot 1 764 | Lot 2 422 |
| | | | | | | E75B*764ESXY | E65B*422ESXY |
| Electrostatic d | ischarge – Charge | Device Model | | T | <u> </u> | l | |
| ESD | ANSI/ESD STM5.3.1 | N.A. | 2 x 3 | 500V (764) | NA | 0/3 | |
| | JEDEC JS-002 | | _ | 500V (422) | | | 0/3 |
| Preconditionin | g: moisture sensitiv | vity level 3 | | T | ı | ı | |
| PC | J-STD-020 JESD22-A113 | MSL3 | 2 x 308 | Electrical test: A0/R1 (Accepted 0 reject/ Rejected 1 reject) | NA | 0/308 | 0/308 |
| | | Delamination | 2 x 60 | No delamination | | 0/60 | 0/60 |
| High Tempera | ture Storage Life at | ter preconditionin | ng | | | 1 | |
| HTSL | JESD 22-A103 | 150°C | 1 x 77 | Elect test A0/R1 | 1000h | 0/77 | |
| Thermal Cyclin | ng after Precondition | ning | | | | | |
| тс | JESD 22-A104 | - | 1 x 77 | Elect test A0/R1 | 500cy | 0/77 | |
| | | 65°C/+150°C | | | 1000cy for monitoring | 0/77 | |
| Unbiased High | nly Accelerated Ten | nperature and Hu | midity Stres | s after Preconditioni | ng I | | |
| uHAST | JESD 22A118 | 130°C, 85%RH 2Atm | 1 x 77 | Elect test A0/R1 | 96h | 0/77 | |
| Biased Highly | Accelerated tempe | rature & humidity | stress Test | after Preconditionin | g | L | |
| HAST | JESD 22A110 | 110°C, 85%RH 1.2atm Bias | 1 x 77 | Elect test A0/R1 | 264h | 0/77 | |
| Construction A | Construction Analysis | | | | | | |
| CA | Construction Analysis including: -Wire bond shear -Wire bond pull -Solderability -Physical Dimension | JESD 22B102 JESDB100/B 108 | 2 x 50 | No concern | NA | No concern | No concern |

Note: The assembly line LQFP7x7 is qualified and in production for STM32 devices in TSMC 0.18µm (please refer to report MDG-MCD-RER1717).

For die 422 in LQFP7x7, only MSL3 CDM and construction analysis were performed to qualify leadframe with slot.

MDG-MCD-RER1810 Page 8 of 21



Package oriented test results in LQFP10x10

| | | Package Rel | | | | LQFI | P 10x10 |
|-----------------|--|-------------------------------------|--------------|---|-----------------------|---------------------|----------------------------|
| Description | Test/Method | Conditions | Sample | Criteria | Readout / | Lot 3 | Lot 4 |
| | | | Size | Orneria | Duration | 411 E45W*411ESX3 | 417 E35W*417ESXX |
| Electrostatic d | ischarge – Charge | Device Model | | | | | |
| ESD | ANSI/ESD STM5.3.1 | N.A. | 2 x 3 | 500V (417) | NA | | 0/3 |
| | JESD22-C101 | | 2 × 0 | 500V (411) | 107 | 0/3 | |
| Preconditionin | g: moisture sensitiv | vity level 3 | ı | | | ľ | l |
| PC | J-STD-020 JESD22-A113 | MSL3 | 2 x 308 | Electrical test: A0/R1 (Accepted 0 reject/ Rejected 1 reject) | NA | 0/308 | 0/308 |
| | | Delamination | 2 x 60 | No delamination | | 0/60 | 0/60 |
| High Tempera | ture Storage Life at | fter preconditionir | ng | | | | |
| HTSL | JESD 22-A103 | 150°C | 2 x 77 | Elect test A0/R1 | 1000h | 0/77 | 0/77 |
| Thermal Cyclin | ng after Precondition | ning | | | | | |
| тс | JESD 22-A104 | - | 2 x 77 | Elect test A0/R1 | 500cy | 0/77 | 0/77 |
| | | 65°C/+150°C | | | 1000cy for monitoring | 0/77 | 0/77 |
| Unbiased High | nly Accelerated Ten | nperature and Hu | midity Stres | s after Preconditioning | | T | T |
| uHAST | JESD 22A118 | 130°C, 85%RH 2Atm | 2 x 77 | Elect test A0/R1 | 96h | 0/77 | 0/77 |
| Temperature H | Humidity Bias after | | | | | | |
| THB | JESD 22-A101 | 85°C/85%RH Bias VDD=3v6 | 2 x 77 | Elect test A0/R1 | 1000h | 0/77 | 0/77 |
| Construction A | Analysis | | | | | | |
| CA | Construction Analysis including: -Wire bond shear -Wire bond pull -Solderability -Physical Dimension | JESD 22B102 JESDB100/B 108 | 2 x 50 | No concern | NA | No concern | No concern |

MDG-MCD-RER1810 Page 9 of 21



Package oriented test results in LQFP14x14

| | Package Related Tests | | | | | | Res | sults | |
|--------------|--|-------------------------------|--------------------|---|-----------------------|----------------------------|----------------------------|---------------------|----------------------------|
| | | | | | | | | 14x14 | |
| Descripti | Test/Method | Conditions | Sample | Criteria | Readout / | Lot 5 | Lot 6 | Lot 7 | Lot 8 |
| on | restilletilou | Containons | Size | Orneria | Duration | 436 E21L*436ESXX | 448 E41L*448ESX1 | 411 E71L*411ESX3 | 435 E31L*435ESXZ |
| Electrostati | ic discharge – Charg | ge Device Model | | | | | | | |
| ESD | ANSI/ESD STM5.3.1 | N.A. | 4 x 3 | 500V (448 & 435) | NA | | 0/3 | | 0/3 |
| | JESD22-C101 | 14.7 (. | 4 X O | 500V (436 & 411) | 14/1 | 0/3 | | 0/3 | |
| Preconditio | ning: moisture sens | itivity level 3 | | | | | | | |
| PC | J-STD-020 JESD22-A113 | MSL3 | 4 x 308 | Electrical test: A0/R1 (Accepted 0 reject/ Rejected 1 reject) | NA | 0/308 | 0/308 | 0/308 | 0/308 |
| | | Delamination | 4 x 60 | No delamination | | 0/60 | 0/60 | 0/60 | 0/60 |
| High Temp | erature Storage Life | after preconditioning | ı | 1 | | | | 1 | |
| HTSL | JESD 22-A103 | 150°C | 4 x 77 | Elect test A0/R1 | 1000h | 0/77 | 0/77 | 0/77 | 0/77 |
| Thermal Cy | cling after Precondi | tioning | | | | | | | |
| TC | JESD 22-A104 | -65°C/+150°C | 4 x 77 | Elect test A0/R1 | 500cy | 0/77 | 0/77 | 0/77 | 0/77 |
| Habia and H | l'abba Assalanata d'T | | al'tra Otana a a a | | 1000cy for monitoring | 0/77 | 0/77 | 0/77 | 0/77 |
| Unblased F | lignly Accelerated I | emperature and Humi | dity Stress a | TTER Precondition | ling | | | I | |
| uHAST | JESD 22A118 | 130°C, 85%RH 2Atm | 4 x 77 | Elect test A0/R1 | 96h | 0/77 | 0/77 | 0/77 | 0/77 |
| Temperatu | re Humidity Bias after | er Preconditioning | | | | | | | |
| THB | JESD 22-A101 | 85°C/85%RH Bias VDD=3v6 | 4 x 77 | Elect test A0/R1 | 1000h | 0/77 | 0/77 | 0/77 | 0/77 |
| Constructio | | | | | | | | | |
| CA | Construction Analysis including: -Wire bond shear -Wire bond pull -Solderability -Physical Dimension | JESD 22B102 JESDB100/B108 | 4 x 50 | No concern | NA | No concern | No concern | No concern | No concern |

MDG-MCD-RER1810 Page 10 of 21



Package oriented test results in LQFP20x20

| | | Package Related | Tests | | | | Results | |
|-----------------|--|-------------------------------|----------------|---|-----------------------|--------------|---------------|---------------|
| Decembrati | | | Commis | | Decelout / | | LQFP 20x20 | |
| Descripti on | Test/Method | Conditions | Sample Size | Criteria | Readout / Duration | Lot 9 414 | Lot 10 413 | Lot 11 450 |
| | | | | | | E01A*414ESX3 | E01A*413ESX2 | E01A*450ESXY |
| Electrostati | ic discharge – Charg | e Device Model | | I | l | I | | |
| | JESD22-C101 | | | 500V for 414 | | 0/3 | | |
| ESD | ANSI/ESD STM5.3.1 | N.A. | 4 x 3 | 250V for 414 500V for 413 | N.A. | 0/3 | 0/3 | |
| | JEDEC JS-002 | | | 250V for 450 | | | | 0/3 |
| Preconditio | ning: moisture sensi | tivity level 3 | I | T | T | T | | T |
| PC | J-STD-020 JESD22-A113 | MSL3 | 3 x 308 | Electrical test: A0/R1 (Accepted 0 reject/ Rejected 1 reject) | NA | 0/308 | 0/308 | 0/308 |
| | | Delamination | 3 x 60 | No delamination | | 0/60 | 0/60 | 0/60 |
| High Temp | erature Storage Life | after preconditioning | ī | 1 | | | | |
| HTSL | JESD 22-A103 | 150°C | 3 x 77 | Elect test A0/R1 | 1000h | 0/77 | 0/77 | 0/77 |
| Thermal Cy | cling after Precondi | tioning | | | | | | |
| TC | JESD 22-A104 | -65°C/+150°C | 3 x 77 | Elect test | 500cy | 0/77 | 0/77 | 0/77 |
| | | 55 5/1155 | | A0/R1 | 1000cy for monitoring | 0/77 | 0/77 | |
| Unbiased F | lighly Accelerated Te | emperature and Humi | dity Stress a | fter Precondition | ning | | | |
| uHAST | JESD 22A118 | 130°C, 85%RH 2Atm | 3 x 77 | Elect test A0/R1 | 96h | 0/77 | 0/77 | 0/77 |
| Temperatui | re Humidity Bias afte | | , | | | | | |
| THB | JESD 22-A101 | 85°C/85%RH Bias VDD=3v6 | 3 x 77 | Elect test A0/R1 | 1000h | 0/77 | 0/77 | 0/77 |
| Constructio | n Analysis | | | | | | | |
| CA | Construction Analysis including: -Wire bond shear -Wire bond pull -Solderability -Physical Dimension | JESD 22B102 JESDB100/B108 | 3 x 50 | No concern | NA | No concern | No concern | No concern |

MDG-MCD-RER1810 Page 11 of 21



3 RELIABILITY TEST VEHICLES CHARACTERISTICS

3.1 Front-End information

Front-end information in LQFP7x7

| Front-End | Diffusion FAB | | | | | |
|--|--|--|--|--|--|--|
| | Lot 1 | | Lot 2 | | | |
| | 764 E75B*764ESX | Υ | 422 E65B*422ESX | Y | | |
| Wafer Fab | ROUSSET | R8 | TSMC Fab | 11 | | |
| Name | | - 10 | US | | | |
| Wafer Fab Location/ Address | 190 Avenue Celo COQ, 13106 Rous FRANCE | sset | 5509 N W Parker Street CAMAS WA 98607-9299 U.S. | | | |
| Process Technology Name | CMOSF9G | 02 | CMOS M8 0.18µm E FLASH | EMBEDDED | | |
| Wafer Diameter | 8 inches | 3 | 8 inches | | | |
| Wafer Thickness | 375 +/- 25 | μm | 375 +/- 25 μm | | | |
| Die Size | X: 1738 μ Y: 2876 μ 5.0 mm² | m | X: 4236 μm Y: 4698 μm 19.9 mm² | | | |
| Technology Mask Number | 39 | | 34 | | | |
| Scribe Line size x/y: | 80 µm x 80 | μm | 80 μm x 80 μm | | | |
| Pad Die Size /Pad type: | 65 μm x 108 | 3 µm | 65 μm x 70 | μm | | |
| Metal Layers Number Materials Thickness | Metal 1 TaN/Ta/Cu Metal 2 TaN/Ta/Cu Metal 3 TaN/Ta/Cu Metal 4 TaN/Ta/Cu Metal 5 Ti/AlCu/TxTN | 0.280 μm 0.350 μm 0.350 μm 0.350 μm 0.900 μm | Metal 1 Tin/AlCu/Tin Metal 2 Tin/AlCu/Tin Metal 3 Tin/AlCu/Tin Metal 4 Tin/AlCu/Tin Metal 5 Tin/AlCu/Tin | 0.450 µm 0.450 µm 0.450 µm 0.450 µm 0.875 µm | | |
| Passivation Layers Number Materials Thickness | USG + NitUV (HFP USG+UV Nitride) 1.75µm | | HDPox 10kA+SRO 1.5kA+PESIN 6kA 1.75μm | | | |
| Back Metal Finishing Thickness | RAW SILICON - BAC | K GRINDING | RAW SILICON - BAC | K GRINDING | | |

MDG-MCD-RER1810 Page 12 of 21



Front-end information in LQFP10x10

| Front-End | Diffusion FAB | | | | | |
|--|--|--|--|--|--|--|
| | Lot 3 | Lot 4 | | | | |
| | 411 E45W*411ESX3 | 417 E35W*417ESXX | | | | |
| Wafer Fab Name | TSMC Fab14 Taiwan | ROUSSET R8 | | | | |
| Wafer Fab Location/ Address | No. 1-1, Nan- Ke North Rd., Southern Taiwan Science Park,741-44 TAIWAN | 190 Avenue Celestin COQ, 13106 Rousset FRANCE | | | | |
| Process Technology Name | CMOSM10ULP 6M1T | CMOSF9GO2S | | | | |
| Wafer Diameter | 12 inches | 8 inches | | | | |
| Wafer Thickness | 775 +/- 25 μm | 375 +/- 25 μm | | | | |
| Die Size | X: 4006 μm Y: 3674 μm 14.7 mm² | X: 2903 μm Y: 2631 μm 7.6 mm² | | | | |
| Technology Mask Number | 42 | 37 | | | | |
| Scribe Line size x/y: | 80 μm x 80 μm | 80 µm x 80 µm | | | | |
| Pad Die Size /Pad type: | 59 μm x 123 μm 63 μm x 73 μm | 53 μm x 108 μm | | | | |
| Metal Layers Number Materials Thickness | Metal 1 TaN/Ta/CuSeed/Cu 0.220 μm Metal 2 TaN/Ta/CuSeed/Cu 0.280 μm Metal 3 TaN/Ta/CuSeed/Cu 0.280 μm Metal 4 TaN/Ta/CuSeed/Cu 0.280 μm Metal 5 TaN/Ta/CuSeed/Cu 0.280 μm Metal 6 Ta/TaN/AlCu 0.730 μm Metal 7 AlCu 1.200 μm | Metal 1 TaN/Ta/Cu 0.280 µm Metal 2 Ti/AlCu/TxTN 0.310 µm Metal 3 Ti/AlCu/TxTN 0.310 µm Metal 4 Ti/AlCu/TxTN 0.310 µm Metal 5 Ti/AlCu/TxTN 1.200 µm | | | | |
| Passivation Layers Number Materials Thickness | USG + NITRIDE 1.75μm | USG + NitUV (HFP USG+UV Nitride) 1.2 µm | | | | |
| Back Metal Finishing Thickness | RAW SILICON | RAW SILICON - BACK GRINDING | | | | |

MDG-MCD-RER1810 Page 13 of 21



Front-end information in LQFP14x14

| <u>Front-en</u> | d information in LQFP | <u>14X14</u> | | |
|---|---|--|--|---|
| Front-End | | | Diffusion FAB | |
| | Lot 5 | Lot 6 | Lot 7 | Lot 8 |
| | 436 E21L*436ESXX | 448 E41L*448ESX1 | 411 E71L*411ESX3 | 435 E31L*435ESXZ |
| Wafer Fab Name | ROUSSET R8 | TSMC Fab8 - Taiwan | TSMC Fab14 - Taiwan | TSMC Fab14 - Taiwan |
| Wafer Fab Location/ Address | 190 Avenue Celestin COQ, 13106 Rousset FRANCE | No. 1-1, Nan-Ke North Rd., Southern Taiwan Science Park,741-44 TAIWAN | No. 1-1, Nan- Ke North Rd., Southern Taiwan Science Park,741-44 TAIWAN | No. 1-1, Nan- Ke North Rd., Southern Taiwan Science Park,741-44 TAIWAN |
| Process Technology Name | CMOSF9GO2 | CMOS M8 0.18µm EMBEDDED FLASH | CMOSM10ULP 6M1T | 90nm eFlash Generic TSMC |
| Wafer Diameter | 8 inches | 8 inches | 12 inches | 12 inches |
| Wafer Thickness | 375 +/- 25 μm | 381 +/- 25 μm | 775 +/- 25 μm | 775 +/- 25 μm |
| Die Size | X: 4574 μm Y: 4946 μm 22.6 mm² | X: 3312 μm Y: 3144 μm 10.4 mm² | X: 4006 μm Y: 3674 μm 14.7 mm² | X: 3176.4 μm Y: 3162.4 μm 10.0 mm² |
| Technology Mask Number | 38 | 34 | 42 | 44 |
| Scribe Line size x/y | 80 µm x 80 µm | 80 µm x 80 µm | 80 µm x 80 µm | 80 µm x 80 µm |
| Pad Die Size /Pad type | 65 µm x 108 µm | 65 μm x 70 μm | 59 μm x 123 μm 63 μm x 73 μm | 123 µm x 59 µm |
| Metal Layers Number Materials Thickness | Metal 1 TaN/Ta/Cu 0.280 µm Metal 2 TaN/Ta/Cu 0.350 µm Metal 3 TaN/Ta/Cu 0.350 µm Metal 4 TaN/Ta/Cu 0.350 µm Metal 5 Ti/AlCu/TxTN 0.900 µm | Metal 1 Tin/AlCu/Tin 0.450 μm Metal 2 Tin/AlCu/Tin 0.450 μm Metal 3 Tin/AlCu/Tin 0.450 μm Metal 4 Tin/AlCu/Tin 0.450 μm Metal 5 Tin/AlCu/Tin 0.875 μm | Metal 1 TaN/Ta/CuSeed/Cu 0.220 μm Metal 2 TaN/Ta/CuSeed/Cu 0.280 μm Metal 3 TaN/Ta/CuSeed/Cu 0.280 μm Metal 4 TaN/Ta/CuSeed/Cu 0.280 μm Metal 5 TaN/Ta/CuSeed/Cu 0.280 μm Metal 5 TaN/Ta/CuSeed/Cu 0.280 μm Metal 6 Ta/TaN/AlCu 0.730 μm Metal 7 AlCu 1.200 μm | Metal 1 TaN/Ta/CuSeed/Cu 0.240 μm Metal 2 TaN/Ta/CuSeed/Cu 0.310 μm Metal 3 TaN/Ta/CuSeed/Cu 0.310 μm Metal 4 TaN/Ta/CuSeed/Cu 0.310 μm Metal 5 TaN/Ta/CuSeed/Cu 0.310 μm Metal 6 TaN/Ta/CuSeed/Cu 0.850 μm Metal 7 AlCu 1.450 μm |
| Passivation Layers Number Materials Thickness | USG + NitUV (HFP USG+UV Nitride) 1.75µm | HDPox 10kA+SRO 1.5kA+PESIN 6kA 1.75µm | USG + NITRIDE 1.75μm | USG + NITRIDE 1.75μm |
| Back Metal Finishing Thickness | RAW SILICON - BACK GRINDING | RAW SILICON - BACK GRINDING | RAW SILICON | RAW SILICON |

MDG-MCD-RER1810 Page 14 of 21



Front-end information in LQFP20x20

| Front-End | | Diffusion FAB | |
|--|--|---|--|
| Front-End | Lot 9 | Lot 10 | Lot 11 |
| | 414 | 413 | 450 |
| Wafer Fab | E01A*414ESX3 | E01A*413ESX2 | E01A*450ESXY |
| Name | TSMC Fab8 Taiwan | ST Crolles 300 | ST Crolles 300 |
| Wafer Fab Location/ Address | No. 1-1, Nan-Ke North Rd., Southern Taiwan Science Park,741-44 TAIWAN | 850 rue Jean MONNET 38920 Crolles FRANCE | 850 rue Jean MONNET 38920 Crolles FRANCE |
| Process Technology Name | CMOS0.18μm Emb.Flash | CMOSM10LP 6M1T | CMOSM40 |
| Wafer Diameter | 8 inches | 12 inches | 12 inches |
| Wafer Thickness | 375 +/- 25 μm | 775 +/- 25 μm | 775 +/- 25 μm |
| Die Size | X: 4511 μm Y: 4440 μm 20.0 mm² | X: 4004 μm Y: 4258 μm 17.0 mm² | X:4983 μm Y: 4662 μm 23.2 mm² |
| Technology Mask Number | 31 | 41 | 50 |
| Scribe Line size x/y | 80.6 μm x 80.2 μm | 80 µm x 80 µm | 72 μm x 72 μm |
| Pad Die Size /Pad type | 65 μm x 70 μm | 59 μm x 123 μm 63 μm x 73 μm | 54.9 μm x 54.4 μm |
| Metal Layers Number Materials Thickness | Metal 1 Tin/AlCu/Tin 0.450 μm Metal 2 Tin/AlCu/Tin 0.450 μm Metal 3 Tin/AlCu/Tin 0.450 μm Metal 4 Tin/AlCu/Tin 0.450 μm Metal 5 Tin/AlCu/Tin 0.875 μm | Metal 1 TaN/CuSeed/Cu 0.240 μm Metal 2 TaN/CuSeed/Cu 0.330 μm Metal 3 TaN/CuSeed/Cu 0.330 μm Metal 4 TaN/CuSeed/Cu 0.330 μm Metal 5 TaN/CuSeed/Cu 0.330 μm Metal 6 TaN/CuSeed/Cu 0.850 μm Metal 7 AlCu/TinArc 1.450 μm | Metal 1 Cu 0.130 μm Metal 2 Cu 0.140 μm Metal 3 Cu 0.140 μm Metal 4 Cu 0.140 μm Metal 5 Cu 0.140 μm Metal 6 Cu 0.140 μm Metal 7 Cu 1.000 μm Metal 8 Ta/TaN/AlCu 1.450 μm |
| Passivation Layers Number Materials Thickness | HDPox 10kA+SRO 1.5kA+PESIN 6kA 1.75μm | PSG + NITRIDE 1.1μm | PSG + NITRIDE 1.1µm |
| Back Metal Finishing Thickness | RAW SILICON - BACK GRINDING | RAW SILICON | RAW SILICON |

MDG-MCD-RER1810 Page 15 of 21



3.2 Back-End information

Back-end information in LQFP7x7

| Back-End | Lot 1 764 _{E75B*} 764ESXY | Lot 2 422 _{E65B} -422ESXY | | |
|---|--|---|--|--|
| Assembly Plant Location/ Address: | No.26, Chin 3rd Rd. Nantze, Kaohsiung, Taiwan | | | |
| Die Thickness after Back grinding: | NA | NA | | |
| Die sawing method: | Step cut | | | |
| Die attach material: Type: Supplier: | GLUE CRM 1076WA Sumitomo | | | |
| Lead frame material: Die paddle size: | Copper Frame Spot Ag 4.092 mm x 4.092 mm | Copper Frame Spot Ag 5.0 mm x 5.0 mm | | |
| Wire bonding: Type /Diameter: | | RE Au 8 mil | | |
| Lead Plating Natures Thickness | Pure Tin (e3) Tolerance 7 to 20 µm | | | |
| Molding Compound Supplier: | EME-G631SH Sumitomo | | | |
| Package Moisture Sensitivity Level (JEDEC J-STD020D): | 3 (1 WEEK at <=30C/60%RH) | | | |

MDG-MCD-RER1810 Page 16 of 21



Back-end information in LQFP10x10

| Back-End | Lot 3 411 E45W*411ESX3 | Lot 4 417 E35W*417ESXX | | | |
|---|--|---|--|--|--|
| Assembly Plant Location/ Address: | No.26, Chin 3rd Rd. Nantze, Kaohsiung, Taiwan | | | | |
| Die Thickness after Back grinding: | 375 +/- 25 μm | NA | | | |
| Die sawing method: | Step cut | | | | |
| Die attach material: Type: Supplier: | GLUE CRM 1076WA Sumitomo | | | | |
| Lead frame material: Die paddle size: | Copper Frame Spot Ag 5.7 mm x 5.7 mm | Copper Frame Spot Ag 5.7 mm x 5.7 mm | | | |
| Wire bonding: Type /Diameter: | | RE Au 3 mil | | | |
| Lead Plating Natures Thickness | Pure Tin (e3) Tolerance 7 to 20 μm | | | | |
| Molding Compound Supplier: | EME-G631SH Sumitomo | | | | |
| Package Moisture Sensitivity Level (JEDEC J-STD020D): | (1 WEEK at < | 3 =30C/60%RH) | | | |

MDG-MCD-RER1810 Page 17 of 21



Back-end information in LQFP14x14

| Back-End | Lot 5 | Lot 6 | Lot 7 | Lot 8 |
|---|---------------------------------------|--------------|---------------|---------------|
| | 436 | 448 | 411 | 435 |
| | _{E21L*436ESXX} | E41L*448ESX1 | E71L*411ESX3 | E31L*435ESXZ |
| Assembly Plant Location/ | No.26, Chin 3rd Rd. | | | |
| Address: | Nantze, Kaohsiung, Taiwan | | | |
| Die Thickness after Back grinding: | NA | NA | 375 +/- 25 μm | 375 +/- 25 μm |
| Die sawing method: | Step cut | | | |
| Die attach material: | GLUE | | | |
| Type: | CRM 1076WA | | | |
| Supplier: | Sumitomo | | | |
| Lead frame material: | Copper Frame Spot Ag | | | |
| Die paddle size: | 6.6 mm x 6.6 mm | | | |
| Wire bonding: | WIRE Au | | | |
| Type /Diameter: | 0.8 mil | | | |
| Lead Plating Natures Thickness | Pure Tin (e3) Tolerance 7 to 20 μm | | | |
| Molding Compound Supplier: | EME-G631SH Sumitomo | | | |
| Package Moisture Sensitivity Level (JEDEC J-STD020D): | 3 (1 WEEK at <=30C/60%RH) | | | |

MDG-MCD-RER1810 Page 18 of 21



Back-end information in LQFP20x20

| Back-End | Lot 9 | Lot 10 | Lot 11 |
|---|---------------------------------------|-------------------------|---------------------------------------|
| | 414 | 413 | 450 |
| | _{E01A*414ESX3} | _{E01A*413ESX2} | E01A*450ESXY |
| Assembly Plant Location/ | No.26, Chin 3rd Rd. | | |
| Address: | Nantze, Kaohsiung, Taiwan | | |
| Die Thickness after Back grinding: | NA 375 +/- 20 μm 300 | | 300 +/- 25 μm |
| Die sawing method: | Step cut | | Laser Grooving + Mechanical dicing |
| Die attach material: | GLUE | | |
| Type: | CRM 1076WA | | |
| Supplier: | Sumitomo | | |
| Lead frame material: | Copper Frame Spot Ag | | |
| Die paddle size: | 6.6 mm x 6.6 mm | | |
| Wire bonding: | WIRE Au | | |
| Type /Diameter: | 0.8 mil | | |
| Lead Plating Natures Thickness | Pure Tin (e3) Tolerance 7 to 20 μm | | |
| Molding Compound Supplier: | EME-G631SH Sumitomo | | |
| Package Moisture Sensitivity Level (JEDEC J-STD020D): | 3 (1 WEEK at <=30C/60%RH) | | |

MDG-MCD-RER1810 Page 19 of 21



4 APPLICABLE AND REFERENCE DOCUMENTS

| DMS 0061692 : | Reliability Tests And Criteria For Qualifications | | |
|--------------------|---|--|--|
| SOP 2.6.2: | Process qualification and transfer management | | |
| SOP 2.6.7: | Product Maturity Level | | |
| SOP 2.6.9: | Package and process maturity management in Back End | | |
| SOP 2.6.11: | Program management from product qualification | | |
| SOP 2.6.19: | Process maturity level | | |
| ANSI/ESD STM5.3.1: | Electrostatic discharge (ESD) sensitivity testing charge device model (CDM) | | |
| JESD22-C101: | Electrostatic discharge (ESD) sensitivity testing charge device model (CDM) | | |
| JEDEC JS-002: | Electrostatic discharge (ESD) sensitivity testing charge device model (CDM) | | |
| JESD 22-A103: | High Temperature Storage Life | | |
| J-STD-020: | Moisture/reflow sensitivity classification for non-hermetic solid state surface mount | | |
| | devices | | |
| JESD22-A113: | Preconditioning of non-hermetic surface mount devices prior to reliability testing | | |
| JESD22-A118: | Unbiased Highly Accelerated temperature & humidity Stress Test | | |
| JESD22-A104: | Temperature cycling | | |
| JESD22-A110: | Biased Highly Accelerated temperature & humidity stress | | |
| JESD22-A101: | Temperature Humidity Bias | | |
| JESD 22B102: | Solderability test | | |
| JESD22B100/B108: | Physical dimension | | |

5 GLOSSARY AND TESTS DESCIPTION

| PC | Preconditioning (solder simulation) | | |
|---------|--|--|--|
| HAST | Biased Highly Accelerated temperature & humidity stress Test | | |
| THB | Temperature Humidity Bias | | |
| TC | Temperature cycling | | |
| uHAST | Unbiased Highly Accelerated Stress Test | | |
| HTSL | High temperature storage life | | |
| DMS | ST Advanced Documentation Controlled system/ Documentation | | |
| | Management system | | |
| ESD CDM | Electrostatic discharge (charge device model) | | |
| CA | Construction Analysis | | |

6 REVISION HISTORY

| Revision | Date | Author | Comment |
|----------|------------------|--------------------------|--|
| 1 | 30 Nov., 2018 | B. Routier- Scappucci | Release for production LQFP7x7& LQFP10x10 |
| 2 | 15 Jan., 2019 | B. Routier- Scappucci | Correction typo errors and added LQFP14x14 package |
| 3 | 25 Apr., 2019 | B. Routier- Scappucci | Added LQFP20x20 package |
| 4 | 25 Jun., 2019 | B. Routier- Scappucci | Added results on die 450 LQFP20x20 |
| 5 | 23 Jun., 2021 | B. Routier- Scappucci | Added new PCN12854 for additional products in LQFP7x7: STM32G0/STM32G03/STM32G05/STM32L46x/STM32L4P/STM32L5 families |

MDG-MCD-RER1810 Page 20 of 21



IMPORTANT NOTICE - PLEASE READ CAREFULLY

STMicroelectronics International NV and its affiliates ("ST") reserve the right to make changes corrections, enhancements, modifications, and improvements to ST products and/or to this document any time without notice.

This document is provided solely for the purpose of obtaining general information relating to an ST product. Accordingly, you hereby agree to make use of this document solely for the purpose of obtaining general information relating to the ST product. You further acknowledge and agree that this document may not be used in or in connection with any legal or administrative proceeding in any court, arbitration, agency, commission or other tribunal or in connection with any action, cause of action, litigation, claim, allegation, demand or dispute of any kind. You further acknowledge and agree that this document shall not be construed as an admission, acknowledgement or evidence of any kind, including, without limitation, as to the liability, fault or responsibility whatsoever of ST or any of its affiliates, or as to the accuracy or validity of the information contained herein, or concerning any alleged product issue, failure, or defect. ST does not promise that this document is accurate or error free and specifically disclaims all warranties, express or implied, as to the accuracy of the information contained herein. Accordingly, you agree that in no event will ST or its affiliates be liable to you for any direct, indirect, consequential, exemplary, incidental, punitive, or other damages, including lost profits, arising from or relating to your reliance upon or use of this document.

Purchasers should obtain the latest relevant information on ST products before placing orders. ST products are sold pursuant to ST's terms and conditions of sale in place at the time of order acknowledgement, including, without limitation, the warranty provisions thereunder.

In that respect please note that ST products are not designed for use in some specific applications or environments described in above mentioned terms and conditions.

Purchasers are solely responsible for the choice, selection, and use of ST products and ST assumes no liability for application assistance or the design of Purchasers' products.

Information furnished is believed to be accurate and reliable. However, ST assumes no responsibility for the consequences of use of such information nor for any infringement of patents or other rights of third parties which may result from its use. No license, express or implied, to any intellectual property right is granted by ST herein.

Resale of ST products with provisions different from the information set forth herein shall void any warranty granted by ST for such product.

ST and ST logo are trademarks of ST. All other product or service names are the property of their respective owners.

Information in this document supersedes and replaces information previously in any prior version of this document.

© 2021 STMicroelectronics - All rights reserved

MDG-MCD-RER1810 Page 21 of 21